



Docket No.: 209211US0

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

OBLON
SPIVAK
McCLELLAND
MAIER
&
NEUSTADT
P.C.

RE: Application Serial No.: 09/866,732
Applicants: Yukihiko SHIRAKAWA
Filing Date: MAY 30, 2001
For: THIN FILM EL DEVICE AND PREPARATION METHOD
Group Art Unit: 2879
Examiner: HARPER, H.

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SIR:

Attached hereto for filing are the following papers:

Executed 2p. DECLARATION UNDER 37 C.F.R. §1.132

w. 2p. Attachment (Photocopies of Photographs)

Our check in the amount of \$ -0- is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

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JUL 15 2003

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